AND TRADEMARK OFFICE IN THE UNITED STATES PAPENT

NOV 1 5 1999

IN RE APPLICATION OF: ADAMS

SERIAL NO.: 09/049,314

FILED: 3/27/98

T: 3652 EXAMINER: Bucci, D.

TITLE: SUBSTRATE PROCESSING APPARATUS WITH SMALL BATCH LOAD

LOCK

ATTORNEY DOCKET NO.: 390P007204-US(PAR)

The Commissioner of Patents and Trademarks Washington, D.C. 20231

AMENDMENT

Sir:

01 FC:103

This is in response to the Office Action mailed 8/11/99 (Paper no. 5) in regard to the above-identified patent application. Please amend the application as follows:

IN THE CLAIMS:

Please amend the Claims as indicated below:

- 1. (Amended) A substrate load lock comprising:
- a frame forming at least three chambers; and

a substrate support movably mounted to the frame to move relative to the frame from an initial position to a final position, the substrate support having at least two separate support areas, a first one of the support 11/23/1999 TWILLIAE 000000 areas being movable between a first one of the chambers 36.30 E_7 and a second one of the chambers, and [,] a second one

11/17/1999 KZEWDIE 00000036 090493;